



**ELECTRONIC COPY**

LG762530827  
Report verification at igi.org



January 3, 2026

IGI Report Number **LG762530827**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.67 - 8.74 X 5.32 MM**

**GRADING RESULTS**

Carat Weight **2.50 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

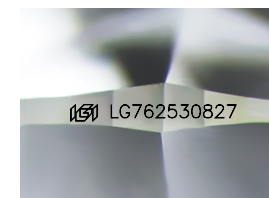
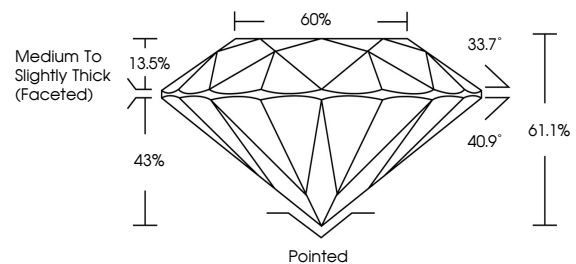
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG762530827**

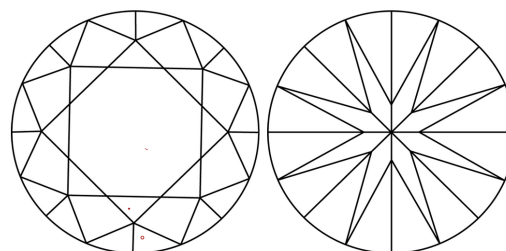
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

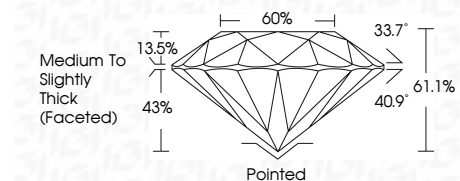
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**ROUND BRILLIANT**  
8.67 - 8.74 X 5.32 MM  
2.50 CARATS  
E  
Color Grade  
VS 1  
Clarity Grade  
EXCELLENT  
Depth  
61.1%  
60%  
Medium To Slightly Thick (Faceted)  
Pointed  
EXCELLENT  
Symmetry  
EXCELLENT  
Fluorescence  
NONE  
Inscription(s)  
IGI LG762530827  
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